

FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
MICRON.272AAPPLICATION NO.
10/666,586INFORMATION DISCLOSURE STATEMENT
BY APPLICANT

USE SEVERAL SHEETS IF NECESSARY)

APPLICANT
GiltonFILING DATE
September 18, 2003GROUP
2877

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
SN	US 2002/0163828 A1	11/7/02	Krieger et al.			
SN	US 2002/0163831 A1	11/7/02	Krieger et al.			

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

EXAMINER
INITIAL

OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

SN	Advertisement for KLA-TENCOR CORPORATION, Unpatterned Surface Inspection Solution, 2 pages (2001).
SN	Falster, "Gettering in silicon: fundamentals and recent advances," <i>Semiconductor Fabtech</i> , 13 th Edition, pp. 1-14 (2001).
SN	Kamigaito et al., "Metal-Catalyzed Living Radical Polymerization," <i>Chem. Rev.</i> , no. 101, pp. 3689-3745 (2001).

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EXAMINER

DATE CONSIDERED

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